

Poster Session 4

March 6(Thu) 11:00-12:30

06aP01 **Evaluation the Reaction of Br radical at Silicon Surface in an Inductively Coupled HBr Plasma**

<sup>1</sup>Y. Fujii, <sup>1</sup>D. Iino, <sup>1,2</sup>H. Toyoda

<sup>1</sup>Nagoya University, Japan

<sup>2</sup>Nagoya University, Japan

06aP02 **A high temperature etching of GaN employing CH<sub>4</sub>/H<sub>2</sub> Gases**

T. Kako, Z. Liu, K. Ishikawa, K. Takada, H. Kondo, O. Oda, M. Sekine, M. Hori

Nagoya University, Japan

06aP03 **Mechanism of Generating Active Species and Etch Reaction in CHxFy Plasma**

Y. Kondo, Y. Miyawaki, K. Takeda, S. Tajima, H. Kondo, K. Ishikawa, T. Hayashi, M. Sekine, M. Hori

Nagoya University, Japan

06aP04 **GaN etching at high temperature employing N<sub>2</sub> added Cl<sub>2</sub> Plasma**

Z. Liu, T. Kako, K. Ishikawa, O. Oda, K. Takeda, H. Kondo, M. Sekine, M. Hori

Nagoya University, Japan

06aP05

**Damage Analysis of N<sub>2</sub> Plasma-etched n-GaN Crystal**

<sup>1</sup>M. Niibe, <sup>1</sup>T. Kotaka, <sup>2</sup>R. Kawakami, <sup>3</sup>Y. Nakano, <sup>4</sup>T. Mukai

<sup>1</sup>University of Hyogo, Japan

<sup>2</sup>The University of Tokushima, Japan

<sup>3</sup>Chubu University, Japan

<sup>4</sup>Nichia Corporation, Japan

06aP06

**Incident Energy Dependence of Reflection Rate of Gas Irradiated on Tungsten**

<sup>1,2</sup>H. Nakamura, <sup>3</sup>S. Saito, <sup>1</sup>A. M. Ito, <sup>1</sup>A. Takayama, <sup>1</sup>Y. Oda

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<sup>2</sup>Nagoya University, Japan

<sup>3</sup>Kushiro National College of Technology, Japan

06aP07

**Atmospheric Pressure Plasma Polymerization of Superhydrophobic Nano-films using Hexamethyldisilazane Monomer**

H. H. Lin, W.C. Ma, J.H. Lin, C. Huang

Yuan Ze University, Taiwan

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06aP08

**A Large Amount Synthesis of Fe-doped TiO<sub>2</sub> Nanopowder using Modulated Induction Thermal Plasmas with Time-Controlled Feeding of Feedstock**

<sup>1</sup>K. Kita, <sup>1</sup>N. Kodama, <sup>1,2</sup>Y. Tanaka, <sup>1,2</sup>Y. Uesugi, <sup>2</sup>T. Ishijima, <sup>3</sup>S. Watanabe, <sup>3</sup>K. Nakamura

<sup>1</sup>Kanazawa University, Japan

<sup>2</sup>Kanazawa University, Japan

<sup>3</sup>Nisshin Seifun Group Inc., Japan

06aP09

**Investigation of TiO<sub>2</sub> Properties Received by Catalytic Plasma Anodization**

A. Bibilashvili, Z. Kushitashvili

Ivane Javakhishvili Tbilisi State University, Georgia

06aP10

**Industrial application of CO<sub>2</sub> decomposition by LAMP (Large flow atmospheric microwave plasma)**

<sup>1</sup>N. Watanabe, <sup>1</sup>H. Fujii, <sup>1</sup>S. Niwa, <sup>1</sup>Y. Morii, <sup>1</sup>S. Ikezawa, <sup>2</sup>N. Nagase

<sup>1</sup>Chubu University, Japan

<sup>2</sup>Nagase Ironworks, Japan

06aP11

**Improvement of Toilet Septic Method using Atmospheric Pressure Plasma**

<sup>1</sup>H. Fujii, <sup>1</sup>S. Niwa, <sup>1</sup>Y. Morii, <sup>1</sup>N. Watanabe, <sup>1</sup>O. Niyomura, <sup>1</sup>S. Ikezawa, <sup>2</sup>N. Nagase

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<sup>2</sup>Nagase Ironworks, Japan

06aP12

**Effect of Ar Flow Rate on the Synthesis of Nanographene Produced from In-liquid Plasma**

<sup>1</sup>J. Jolibois, <sup>1</sup>J. Kularatne, <sup>1</sup>H. Kondo, <sup>2</sup>M. Ito, <sup>3</sup>H. Kano, <sup>1</sup>K. Ishikawa, <sup>2</sup>M. Hiramatsu, <sup>1</sup>M. Hori

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<sup>3</sup>Nu Eco Engineering Co. Ltd., Japan

06aP13

**Slanted Plasma Etching: Fabrication of Three-dimensional Nanostructures**

S. W. Cho, C. K. Kim

Ajou University, Korea

06aP14

**Transport of fine particles produced by interactions between H<sub>2</sub> plasmas and carbon wall**

<sup>1</sup>M. Tateishi, <sup>1</sup>K. Koga, <sup>2</sup>K. Kamataki, <sup>1</sup>D. Yamashita, <sup>1</sup>H. Seo, <sup>1,3</sup>N. Itagaki, <sup>1</sup>M. Shiratani,

<sup>4</sup>N. Ashikawa, <sup>4</sup>S. Masuzaki, <sup>4</sup>K. Nishimura, <sup>4</sup>A. Sagara,

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<sup>3</sup>Presto JST, Japan

<sup>4</sup>National Institute For Fusion Science, Japan

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- 06aP15 **Diamondoid Synthesis in a Supercritical-fluid Microreactor by Ultraviolet Light Irradiation from a Deuterium Dischage Lamp**  
S. Kato, K. Urabe, Y. Matsubayashi, S. Stauss, K. Terashima  
The University of Tokyo, Japan
- 06aP16 **Direct Liquid Injections into Low-Pressure Plasmas**  
<sup>1</sup>D. Ogawa, <sup>1</sup>K. Nakamura, <sup>2</sup>M. Goeckner, <sup>2</sup>L. Overzet  
<sup>1</sup>Chubu University, Japan  
<sup>2</sup>University of Texas at Dallas, USA
- 06aP17 **Understanding the Sorption of Cesium Ion on Bentonite by Plasma Jet**  
<sup>1,2</sup>S. Yang, <sup>1</sup>N. Okada, <sup>2</sup>X. Wang, <sup>1</sup>M. Nagatsu  
<sup>1</sup>Shizuoka University, Japan  
<sup>2</sup>Chinese Academy of Science, China
- 06aP18 **Influence of Gas Species on Synthesis of Metal Nano-particles using Electrolysis with Atmospheric Glow Discharge in Contact with Liquid**  
N. Shirai, T. Ishida, Y. Shimokawa, S. Uchida, F. Tochikubo  
Tokyo Metropolitan University, Japan

06aP19

**Brightening of Tarnished Ag Nanoparticles by Plasma Exposure**

<sup>1</sup>K. Ozaki, <sup>1</sup>M. Yamamoto, <sup>1</sup>N. Terazawa, <sup>2</sup>F. Nishiyama, <sup>1</sup>K. Takahiro

<sup>1</sup>Kyoto Institute of Technology, Japan

<sup>2</sup>Hiroshima University, Japan

06aP20

**Study on Formation of High Density Fe-Nanodots on Ultrathin SiO<sub>2</sub> Induced by Remote H<sub>2</sub> Plasma Exposure**

H. Zhang, K. Makihara, R. Fukuoka, Y. Kabeya, S. Miyazaki

Nagoya University, Japan

06aP21

**Noble Gases Agglomeration in Tungsten Mono-vacancy by Density Functional Calculation**

<sup>1</sup>A. M. Ito, <sup>1</sup>A. Takayama, <sup>1</sup>Y. Oda, <sup>1,2</sup>H. Nakamura

<sup>1</sup>National Institute for Fusion Science, Japan

<sup>2</sup>Nagoya University, Japan

06aP22

**Investigation of Gas Flow Influence on OH Radical Generation Rate in Low Frequency Atmospheric Pressure Plasma Jet**

<sup>1</sup>Y. Imazawa, <sup>2</sup>T. Ishijima, <sup>1</sup>T. Kawae, <sup>1</sup>T. Niwa, <sup>1</sup>K. Nakanishi, <sup>1,2</sup>Y. Tanaka, <sup>1,2</sup>Y. Uesugi

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06aP23

**Reaction Kinetics in 3D Integrated Micro-solution Plasma**

T. Shirafuji

Osaka City University, Japan

06aP24

**Influence of Dispersive Media on Transmitting Efficiency of Waveguide**

<sup>1</sup>Y. Fujita, <sup>2</sup>S. Ikuno, <sup>1,3</sup>H. Nakamura

<sup>1</sup>Nagoya University, Japan

<sup>2</sup>Tokyo University of Technology, Japan

<sup>3</sup>National Institute for Fusion Science, Japan

06aP25

**Hydrogen and Carbon Monoxide Production Using Ethanol Steam Reforming with Gliding Arc Plasma using Different Carrier Gases**

<sup>1</sup>C. P. Hsiao, <sup>2</sup>C. S. Lee, <sup>1</sup>J. S. Wu

<sup>1</sup>National Chiao Tung University, Taiwan

<sup>2</sup>National Chiao Tung University, Taiwan

06aP26

**Detection Method for Metallic Elements in Fishes using Non-Equilibrium Atmospheric Pressure Microplasma**

<sup>1</sup>H. Takemura, <sup>1</sup>T. Ohta, <sup>1</sup>M. Ito, <sup>2</sup>H. Kano, <sup>3</sup>Y. Higashijima, <sup>4</sup>G. Piao, <sup>5</sup>O. Oda, <sup>5</sup>M. Hori

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<sup>2</sup>Nu-Eco Engineering Co. Ltd, Japan

<sup>3</sup>Nu System Inc. Japan

<sup>4</sup>Nanjing Normal University, China

<sup>5</sup>Nagoya University Japan

06aP27

**Orientation Fluctuation in Gallium Nitride Single Crystal grown on Silicon by SEM-EBSD**

H. Morita, T. Egawa

Nagoya Institute of Technology, Japan

06aP28

**Selective Growth of GaN by Liquid Phase Electroepitaxy using Al<sub>2</sub>O<sub>3</sub> Mask**

H. Takakura, M. Tomita, D. Kambayashi, M. Iwakawa, Y. Mizuno, J. Yamada, S. Naritsuka, T. Maruyama

Meijo University. Japan

06aP29

**FTIR Spectra in a Heavily Carbon Doped (0001)GaN**

<sup>1</sup>K. Araki, <sup>1</sup>K. Suzuki, <sup>1</sup>N. Sawaki, <sup>2</sup>K. Yamashita, <sup>2</sup>Y. Honda, <sup>2</sup>H. Amano

<sup>1</sup> Aichi Institute of Technology, Japan

<sup>2</sup> Nagoya University, Japan

06aP30

**Characterization of Traps in AlGaN/GaN HEMTs by Deep Level Transient Spectroscopy**

<sup>1</sup>M. Yoshimoto, <sup>1</sup>K. Miyamoto, <sup>1</sup>Y. Tokuda, <sup>2</sup>T. Katuno, <sup>2</sup>H. Ueda, <sup>2</sup>T. Kachi

<sup>1</sup>Aichi Institute of Technology, Japan

<sup>1</sup>Toyota Central R&D Labs. Inc. Japan

06aP31

**Gan-Based Multi-2DEG-Channel Diodes with Breakdown Voltage of over 3 KV**

<sup>1</sup>A. Terano, <sup>1</sup>T. Tsuchiya, <sup>1</sup>K. Mochizuki, <sup>1</sup>S. Tanaka, <sup>2</sup>Tohru Nakamura

<sup>1</sup>Central Research Laboratory, Hitachi, Ltd, Japan

<sup>2</sup>Research Center For Micro-Nano Technology, Hosei University, Japan

06aP32

**CL Measurement of AlGaN Grown on the Off-Oriented AlN Substrate**

<sup>1</sup>M. Suda, <sup>1</sup>K. Nishino, <sup>2</sup>S. Kurai, <sup>2</sup>Y. Yamada

<sup>1</sup>The University of Tokushima, Japan

<sup>2</sup>Yamaguchi University, Japan

06aP33

**InGaN on Ta-GaN on sapphire substrate switched to the alternative Si wafer**

<sup>1</sup>S. Nakata, <sup>1</sup>S. Sakai, <sup>2</sup>H. Lee

<sup>1</sup>The University of Tokushima, Japan

<sup>2</sup>Soul Opt Device Inc., Korea

06aP34

**Influence of Mg Doping on the Carrier Transport Characteristics of RTA Treated Transparent Zn<sub>1-x</sub>Mg<sub>x</sub>O Nanocrystalline Films**

<sup>1</sup>S. L. Young, <sup>2</sup>C. Y. Kung, <sup>1</sup>H. Z. Chen, <sup>1</sup>M. C. Kao, <sup>2</sup>H. M. Hsieh, <sup>3</sup>J. H. Lin, <sup>2</sup>K. Z. Kan

<sup>1</sup>Hsiuping University of Science and Technology, Taiwan

<sup>2</sup>National Chung Hsing University, Taiwan

<sup>3</sup>Hsiuping University of Science and Technology, Taiwan

06aP35

**Enhancing the luminous efficiency of AlGaInP high power (620nm) light-emitting diodes using Ni/Ag/Ti/Au n-contact**

<sup>1</sup>Y. W. Tu, <sup>1</sup>S. H. Su, <sup>2</sup>L. W. Hung

<sup>1</sup>I-Shou University, Taiwan

<sup>2</sup>Epileds Technology Inc. Taiwan

06aP36

**Characterization of Insulator-Metal Transition of Vanadium Dioxide Films Grown on Titanium and Titanium Nitride layers**

M. S. Mian, K. Okimura

Tokai University, Japan

06aP38

**Low Temperature IGZO Thin-Film Transistor Using High-k Dielectric Materials**

Y. H. Lin, J. C. Chou, W. T. Tsai

National United University, Taiwan

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06aP39

**Structural and Electrical Properties of Ferroelectric  $(\text{Bi},\text{Pr})(\text{Fe},\text{Mn})\text{O}_3$  Thin Films Grown on AlN Substrate**

<sup>1</sup>K. Kinoshita, <sup>1</sup>T. Kawai, <sup>2</sup>H. Naganuma, <sup>1</sup>K. Maekita, <sup>2</sup>S. Nagata, <sup>1</sup>K. Iiyama, <sup>1</sup>A. Morimoto

<sup>1</sup>Kanazawa University, Japan

<sup>2</sup>Tohoku University, Japan

<sup>3</sup>JFE Mineral Company, Ltd., Japan

06aP40

**Polarized Light Emission from Blue-LED with  $\text{SiO}_2$  Subwavelength Grating**

<sup>1</sup>R. Shimizu, <sup>1</sup>Y. Takashima, <sup>1,2</sup>Y. Naoi

<sup>1</sup>The University of Tokushima, Japan

<sup>2</sup>The University of Tokushima, Japan

06aP41

**Improvement of Electron Emission from Semiconductor Surfaces for Photon Enhanced Thermionic Energy Converter**

<sup>1</sup>A. Ogino, <sup>1</sup>T. Setsuda, <sup>2</sup>K. Inoue, <sup>2</sup>K. Shirakura, <sup>2</sup>T. Suzuki, <sup>2</sup>A. Hada

<sup>1</sup>Shizuoka University, Japan

<sup>2</sup>Shizuoka University, Japan

06aP42

**Anisotropic Characteristics of Semi-Polar (1122) GaN Grown on High Temperature Aln and Low Temperature GaN Buffer Layers**

<sup>1</sup>Y. E. Huang, <sup>1</sup>Y. S. You, <sup>1</sup>S. W. Feng, <sup>2</sup>B. Leung, <sup>2</sup>C. D. Yerino, <sup>2</sup>J. Han

<sup>1</sup>National University of Kaohsiung, Taiwan

<sup>2</sup>Yale University, USA

06aP43

**Optical Characteristics of Regularly Patterned Core-Shell Gan/Ingan Quantum Well Nanorad Arrays**

Y. E. Huang, Y. S. You, S. W. Feng

National University of Kaohsiung, Taiwan

06aP44

**AM-MEE growth of InAlN on Si(111) using RF-MBE**

<sup>1</sup>T. Ohachi, <sup>3</sup>O. Ariyada, <sup>2</sup>Y. Sato, <sup>2</sup>S. Yoshikado, <sup>2</sup>M. Wada

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<sup>2</sup>Doshisha University, Japan

<sup>3</sup>Arios Inc., Japan

06aP45

**Annealing Effect on the Microstructural, Optical and Electrical Characteristics of Transparent ZnO Nanocrystalline Films**

<sup>2</sup>C. Y. Kung, <sup>1</sup>S. L. Young, <sup>1</sup>M. C. Kao, <sup>1</sup>H. Z. Chen, <sup>3</sup>H. H. Lin, <sup>2</sup>K. Z. Kan, <sup>3</sup>J. H. Lin

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<sup>2</sup>Hsiuping University Of Science And Technology, Taiwan

<sup>3</sup>Hsiuping University Of Science And Technology, Taiwan

06aP46

**Growth of GaN Nanowire on (111)Si by PA-MBE using High-density Nitrogen Radical Source**

<sup>1</sup>Y. Tsutsumi, <sup>1</sup>S. Mizutani, <sup>1</sup>Y. Honda, <sup>1,2</sup>H. Amano

<sup>1</sup>Nagoya University, Japan

<sup>2</sup>Nagoya University, Japan

06aP47

**The Electrical Properties and Gas Sensing for CVD Growth Indium Nitride**

C. W. Chang, N. J. Ku, C. H. Wang, C. P. Liu

National Cheng Kung University, Taiwan

06aP48

**Growth and Characterization of Nonpolar  $\alpha$ -plane GaN Grown on  $r$ -plane Sapphire using Pulse NH<sub>3</sub> Interruption Etching**

J. S. Son, Y. Honda, H. Amano

Nagoya University, Japan

06aP49

**Nitride-based hetero-field-effect-transistor-type Photosensors with Extremely High Photosensitivity and Complete Solar-blind**

<sup>1</sup>T. Murase, <sup>1</sup>M. Ishiguro, <sup>1</sup>T. Yamada, <sup>1</sup>M. Iwaya, <sup>1</sup>T. Takeuchi, <sup>1</sup>S. Kamiyama, <sup>1,2</sup>I. Akasaki

<sup>1</sup>Meijo University, Japan

<sup>2</sup>Nagoya University, Japan

06aP50

**Current Confinement by Nitride-based Buried Tunnel Junction**

<sup>1</sup>Y. Kuwano, <sup>1</sup>M. Ino, <sup>1</sup>T. Morita, <sup>1</sup>D. Minamikawa, <sup>1</sup>T. Takeuchi, <sup>1</sup>S. Kamiyama, <sup>1</sup>M. Iwaya,

<sup>1,2</sup>I. Akasaki

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<sup>2</sup>Nagoya University, Japan

06aP51

**Tolerances of Angular Apodization and Light Extraction for the Surface Treatment of Light Emitting Diode**

C. J. Ou

Hsiuping University of Science and Technology

06aP52

**Low Resistive GaInN Tunnel Junctions with High InN Mole Fractions**

<sup>1</sup>D. Minamikawa, <sup>1</sup>Y. Kuwano, <sup>1</sup>S. Kawai, <sup>1</sup>T. Morita, <sup>1</sup>T. Takeuchi, <sup>1</sup>S. Kamiyama, <sup>1</sup>M. Iwaya,  
<sup>1,2</sup>I. Akasaki

<sup>1</sup>Meijo University, Japan

<sup>2</sup>Nagoya University, Japan

06aP53

**Improvement of the Light Extraction Efficiency in 350-nm-emission UV Light-emitting Diodes by Novel Distributed Bragg Reflector p-type Electrode**

<sup>1</sup>T. Nakashima, <sup>1</sup>K. Takeda, <sup>1</sup>M. Iwaya, <sup>1</sup>T. Takeuchi, <sup>1</sup>S. Kamiyama, <sup>1,2</sup>I. Akasaki, <sup>2,3</sup>H. Amano  
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<sup>2</sup>Nagoya University, Japan  
<sup>3</sup>Nagoya University, Japan

06aP54

**GaN-Based UV Sensor Array for Integration with Si Sensing Circuit**

<sup>1</sup>A. Takada, <sup>1</sup>S. Ochi, <sup>1</sup>H. Sekiguchi, <sup>1,2</sup>H. Okada, <sup>1</sup>A. Wakahara  
<sup>1</sup>Toyohashi University of Technology, Japan  
<sup>2</sup>Toyohashi University of Technology, Japan

06aP55

**Experimental study on thermal characteristics of P3HT nanowires**

<sup>1</sup>Y. J. Lee, <sup>1</sup>K. W. Sun, <sup>2</sup>T. Y. Ko

<sup>1</sup> National Chiao Tung University, Taiwan

<sup>2</sup> National Chiao Tung University, Taiwan

06aP56

**Thermal Oxidation of Nano-scaled CuO Prepared by Different Heating Method**

<sup>1</sup>H. L. Chen, <sup>2</sup>M. T. Tsai, <sup>3</sup>Y. S. Chang

<sup>1</sup> Kao Yuan University, Taiwan

<sup>2</sup> National Formosa University, Taiwan

<sup>3</sup> National Formosa University, Taiwan

06aP57

**Fabrication of Silver Nano-islands with Zinc Oxide Nanowires based Photoanode**

**Suitable for Photoabsorption-enhancement of Dye-sensitized Solar Cells**

<sup>1</sup>M. M. Rahman, <sup>1</sup>R. Tanaka, <sup>2</sup>S. Kouya, <sup>2</sup>X. Lin, <sup>2</sup>M. Sakai, <sup>2</sup>S. Yagai, <sup>2</sup>K. Kudo, <sup>1</sup>K. Yamamoto

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<sup>2</sup> Chiba University, Japan

06aP58

**Synthesis of Iron Oxide Nanoflakes at Lower Temperature by Air Oxidation of Iron Foils**

<sup>1,2</sup>N. M. Rashid, <sup>1</sup>L. X. Yang, <sup>1</sup>N. Kishi, <sup>1</sup>T. Soga

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06aP59

**Application of Nanosecond Pulsed Plasma to Nanomaterials Synthesis**

E. Omurzak, H. Akiyama, T. Mashimo  
Kumamoto University, Japan

06aP60

**Magnetic and Optical Properties of Nd:Y<sub>3</sub>(Al, Fe)5O<sub>12</sub> Garnet Nanocrystals**

D. Aoki, M. Shima  
Gifu University, Japan

06aP61

**Optical Properties of Palladium-Coated Gold Nanorods**

<Withdrawn> K. Locharoenrat, P. Kittidachaachan  
King Mongkut's Institute of Technology Ladkrabang, Thailand

06aP62

**CdS/CdSe Quantum Dot-Sensitized Solar Cells Based on ZnO Nanoparticle/Nanorod Composite Electrodes**

S. K. Kim, M. K. Son, S. Park, M. S. Jeong, K. Prabakar, H. J. Kim  
Pusan National University, Korea

06aP63

**Electron Field Emission Characteristics of Boron Nanowires grown by Ultra-Low Pressure CVD**

C. H. Wu, Z. Y. Juang, C. K. Hsieh  
Ming Chi University of Technology, Taiwan  
Academia Sinica, Taiwan

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06aP64

**Investigation of the pH effect on the products by the sputtering of gold electrodes during solution plasma**

<sup>1</sup>T. Mizutani, <sup>2</sup>T. Murai, <sup>2</sup>H. Nameki, <sup>3</sup>T. Yoshida, <sup>3</sup>S. Yagi

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<sup>3</sup>Nagoya University, Japan

06aP65

**Piezoelectric Nanogenerator Based on Fabrication of Al-Doped ZnO Nanowires on a Polyimide Substrate**

<sup>1</sup>S. Y. Lin, <sup>1</sup>C. L. Hsu, <sup>1</sup>C. W. Su, <sup>3</sup>T. J. Hsueh

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<sup>1</sup> National University of Tainan, Taiwan

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06aP66

**Plasmonic Metal/Semiconductor Photocatalysts for Efficient Conversion of Light into Chemical Energy**

T. H. Yang, Y. W. Harn, M. C. Chen, J. M. Wu

National Tsing Hua University, Taiwan

06aP67

**Investigation of the Visible Photocatalytic Activity of Ag<sub>2</sub>O Nanocrystals with Controlled Morphology and Facets**

K. C. Chiu, T. H. Yang, J. M. Wu, T. Y. Tang

National Tsing Hua University, Taiwan

06aP68 **Synthesis of 3D Ag-ZnO-Graphene Heterostructures with Highly Efficient and Stable Photocatalytic Performance**

Y. W. Harn, T. H. Yang, M. C. Chen, J. M. Wu

National Tsing Hua University, Taiwan

06aP69 **Synthesis and Characterization of CZTS Nanoparticle**

S. Hori, T. Suzuki, T. Suzuki, K. Uehara, S. Nonomura

<sup>1</sup>Gifu University, Japan

<sup>2</sup>Japan Fine Ceramics Center, Japan

06aP70 **Fabrication of ZnO-Al<sub>2</sub>O<sub>3</sub> Composite Particles by Microwave Plasma Torch**

J. J. Shen, T. C. Wei

Chung-Yuan University, Taiwan

06aP71 **Synthesis of Metal Carbide Nanoparticles by Solution Plasma**

T. Inishi, T. Ban, Y. Ohya

Gifu University, Japan

06aP72 **Control of Dimensions of Copper Oxide Nanowires under Controlled Oxidation Atmosphere**

N. Yokouchi, H. Sato

Mie University, Japan

06aP73

**Hydrothermal Growth of ZnO Nanowall Networks For Near-Ultraviolet Sensors**

J. F. Tang, S. Y. Chu

National Cheng Kung University, Tainan

06aP74

**Kinetics in Gold Nanoparticles Formation by Solution Plasma**

<sup>1</sup>T. Sudare, <sup>1,2,4</sup>T. Ueno, <sup>1,2,3,4</sup>N. Saito

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06aP75

**Study of room temperature ammonia gas sensing properties of zinc oxide and tin monoxide nanowires**

<Withdrawn>

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06aP76

**Coating of Green Synthesized Silver Nanoparticles on Cotton Fabric**

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06aP77

**Comparison between Electrical-Magnetic Modeling and Modified Geometric Rays Approach for the Fabrication of the Nano Structures**

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06aP78LN

**Cyclonic Atmospheric Pressure Plasma Surface Modification Effect on Polysulfone Membrane**

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06aP79LN

**Synthesis of ZnO Nanoparticle in Water by Solution Plasma Processing**

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06aP80LN

**Dominant Violet Luminescence in ZnO Nanorods Treated with High-Energy Hydrogen Plasma**

C. Chen, H. He, Z. Ye

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ISPlasma2014/IC-PLANTS2014 March 2- 6, 2014 Nagoya, Japan

06aP81LN **On the Growth of In-rich InGaN Thin Films by Molecular Beam Epitaxy Using Multiple RF Plasma Cells and Their P-Type Conduction**

T. Matsunaga, H. Takemoto, S. Ishizaki, Y. Murakami, Y. Muraki, T. Aoshima, Y. Sato

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06AP82LN **The relationship between the pressure and the Si etch rate using the reaction of  $F_2 + NO \rightarrow F + FNO$**

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